

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nestor BOJARCZUK JR., et al.

Serial No.: 10/059,422

Group Art Unit: 2814

Filed: January 31, 2002

Examiner: Theresa Doan

For: METHOD OF FORMING LATTICE-MATCHED STRUCTURE ON SILICON AND
STRUCTURE FORMED THEREBY

Honorable Commissioner for Patents
Alexandria, VA 22313-1450
BOX AF

PETITION AND FEE FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136(a)

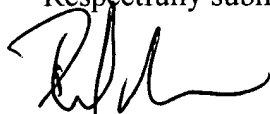
Sir:

Applicant hereby petitions for a One-month extension of time to respond to the Office Action mailed October 20, 2004. The extension fee in the amount of \$ 120.00 is included in the total for the R.C.E. in the amount of \$910. A Request for Continued Examination responsive to the outstanding Office Action is being filed simultaneously herewith. A duplicate copy of this sheet is enclosed.

Please charge Assignee's Deposit Account No. 50-0510 the amount of the \$910.00 for the One-month extension fee and R.C.E. fee.

The Commissioner is authorized charge any deficiencies in fees and credit any overpayment of fees to Assignee's Deposit Account No. 50-0510.

Respectfully submitted,



Phillip E. Miller
Registration No. 46,060

02/22/2005 RFEKADU1 00000064 500510 10059422
02 FC:1251 120.00 DA

Date: 2/18/05

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